

BGA Assembly Generic QC Flow & Control Plan

Process Flow	Operation	Function	Frequency	Sample size
		Visual check for broken wafer	Every wafer	Whole area of wafer back
	Incoming Wafer	wafer backside check for crack and scratch	Every wafer	5 wafer
	Inspection		Every wafer	
		Inspection for die defect		75ea/5 wafers; 9points per wafer
\bigcirc	Backgrinding	Backgrind thickness	Every setup	5 data. 1 wafer
T		Wafer backside roughness measure	1x/shift/machine	1 pcs wafer
		TTV	Every setup	1 pcs wafer
	Wafer saw	Visual check	1x/shift/every change device	50 units
	water saw	Saw Line	Between 5th to 15th line in wafer	Every wafer
\Diamond	2/0 QC Gate	Visual defects	Every wafer lot	125 dies
		Visual inspection	Every set-up	2ea
		Die backside inspection Die tilt	Every setup, Every 8 hrs / MC Every setup, Every 8 hrs / MC	5ea, (2ea monitor) 2ea
		Fillet height	Every setup, Every 8 hrs / MC	2ea
\bigcirc		Epoxy coverage	Every setup, Every 8 hrs / MC	2ea
γ	Die Attach	Die backside chip measurement Die placement	Every setup Every setup, Every 8 hrs / MC	2ea
		Die placement	Every Setup, Every 6 fils / MC	2ea
		Epoxy void	Every setup, Every 12 hrs / MC	2ea, size<100 units 10% lot size; >100 units 10 good dice
		Bondline thickness	Every setup, Every 8 hrs / MC	2ea
	Die Attach Cure	Die shear	per oven/12hours	2ea
\times		Epoxy void	Per day/mc	1 strip
\bigcirc	Plasma clean	Contact angle measurement on die surface	1x / 1day / machine	3ea
		Wire pull test	1x/shift/machine	10 wires
	Wire Bond	Ball shear test	1x/shift/machine	10 balld
\bigcirc		Ball size	Every Setup	I unit,5 wires/ 5 balls
		Ball thickness	Evert Setup	I unit,5 wires/ 5 balls
		Cratering	Every setup	1 ea
		orationing .		
\wedge		Visual inspection	Per lot	125ea: Lot size≤3200, 200ea: 3200 <lot size≤10000<="" th=""></lot>
\vee	3/0 QC Gate			315ea: 10000 < Lot size≤35000 500ea: Lot size>35000
	Plasma clean	Contact angle measurement on die surface	1x / 1day / machine	Every machine
		Visual inspection	Every setup	1st good shot
	Mold	warpage	Every mold die set-up	1st good shot,2unit/strip
		Package thickness	Every mold die set-up	1st good shot,1unit/strip
\searrow		ackage thickness	1X/mold die/MC/shift	1X/mold die/MC/shift (monitor)
	Laser marking	Visual inspection	Every setup; 1X/Shift/Machine	First strip; 1 strips
\perp		Engraving depth	Every setup	5 points of 1st strip
()	Post mold cure	Temperature / time Warpage	3 oven/1shift Per pkg type/size/day	Nil 2 units
\top	. socoid duite	Delamination	3 ovens/ shift	1 strip/Oven
$\overline{\Box}$	Plasma clean	Contact angle measurement on die surface	1x / 1day / machine	Every machine
\top		Reflow Owen	Every Setup	Nil
	Solder Ball	Flux Clean	Every Setup	Nil
\perp		Reflow Profile	Every Setup	Nil
		Solder Ball Diameter	Every Set up; 1X / shift / m/c	10 Ballls form 2 units
$\gamma = \omega$		Solder Ball Height	Every Set up; 1X / shift / m/c	10 Ballls form 2 units
		Solder Ball Shear	Every Set up; 1X / shift / m/c	10 Ballis form 2 units
		Solder Ball Composition Check	Every Set up; 1X / shift / m/c	5 Balls
		Dimension check	Every change of substrate or package type / after mc repair or	5 units
\bigcirc	Saw Singulation	Visual Inspection	idle for 24hrs/ after regular PM / Changing 1-Up half cut into cell (Full Cut) within the same package or vice versa / / After cutting empty ring for check cutting table level	5 units
		F Dimension Check	1x / Setup / machine	5 units
	Pick & Place	Visual Inspection	1x / Setup / machine	5 units
Τ		Ball Coplanarity	Per Lot	125 units(min)
		Ball Diameter	Per Lot	125 units(min)
\wedge	Final visual QC	Visual defects	Per sub-lot	AQL 0.04
$\langle \mathcal{A} \cup \mathcal{A} $	Gate	Side defects visual inspection	Per sub-lot	10 units
~		Reject verification	Per sub-lot	5 units
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Test Generic QC Flow & Control Plan

Process Flow	Process	Function	Frequency	Sample size		
	Electrical Test	EQA buyoff	Every lot	per AQL sampling plan, min 0.065		
	OQA	Visual defects	Every lot	315units/lot		
	Pack	Document, label	Every lot			